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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>					
(use as many sheets as necessary)					
				Application Number	09/900,373
				Filing Date	July 6, 2001
				First Named Inventor	Li et al.
				Group Art Unit	2881
				Examiner Name	N/A
Sheet	1	of	3	Attorney Docket Number	NUFO 003

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Examiner Initials'	Cite No. <sup>1</sup>	U.S. Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code <sup>2</sup> (if known)		
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Reviewing

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		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)		
✓		EP	0924628	Kessenich et al.	8/11/1998	
✓		WO	98/44424	Marmor et al.	10/8/1998	

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OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
HV		Favre et al.: 'External-Cavity Semiconductor Laser With 15 nm Continuous Tuning Range', Electronics Letters June 19, 1986	
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Examiner Signature	<i>JL</i>	Date Considered	10/18/01
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